

Notice of References Cited	Application/Control No. 09/342,348	Applicant(s)/Patent Under Reexamination BROSNIHAN ET AL.	
	Examiner Anh D. Mai	Art Unit 2814	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5747353	05-1998	Bashir et al.	438/50
	C	US-			
	D	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	M. de Boer et al., The Black Silicon Method V: A Study of The Fabricating of Movable Structures for Micro Electromechanical Systems. IEEE 1995, pp. 565-568.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.